Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	(array adj1 microelectronic) and (semiconductor) and (bonding adj1 promoting adj1 layer) and (metal adj1 conductor) and (diffusion adj1 barrier)	US-PGPUB; USPAT	OR	OFF	2005/09/12 15:21

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	IS&R	L1	1	("6680213").PN.	US-PGPUB; USPAT; USOCR	2005/09/12 12:43	
2	IS&R	L2	637	(257/421).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO	2005/09/12 12:47	
3	BRS	L3	210	2 and @ad<="19991026"	US-PGPUB; USPAT; USOCR; EPO; JPO	2005/09/12 12:51	
4	IS&R	L4	1	("6391658").PN.	US-PGPUB; USPAT; USOCR	2005/09/12 12:54	
5	IS&R	L5	273	(257/422).CCLS.	US-PGPUB; USPAT; USOCR	2005/09/12 12:59	
6	IS&R	L6	1549	(257/295).CCLS.	US-PGPUB; USPAT; USOCR	2005/09/12 13:00	

	Error Definition	Errors
1		
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	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
7	BRS	L7	484	6 and @ad<="19991026"	US-PGPUB; USPAT	2005/09/12 13:00	

	Error Definition	Err ors
7		